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(71) Applicant (for all designated States except US): **FUJI PHOTO FILM CO., LTD.** [JP/JP]; 210, Nakanuma, Minami-Ashigara-shi, Kanagawa 250-0193 (JP).

(72) Inventor; and

(75) Inventor/Applicant (for US only): **TATEISHI, Tomomi** [JP/JP]; c/o Fuji Photo Film Co., Ltd., 210, Nakanuma, Minami-Ashigara-shi, Kanagawa 250-0193 (JP).

(74) Agent: **TAKAISHI, Kitsuma**; 67, Kagurazaka 6-chome, Shinjuku-ku, Tokyo 162-0825 (JP).

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(54) Title: ORGANIC THIN-FILM DEVICE AND ITS PRODUCTION METHOD

(57) Abstract: A method for producing an organic thin-film device comprising the steps of (a) heating and/or pressing a transfer material having an organic thin-film layer formed on a temporary support and a first laminate comprising a substrate and at least a transparent conductive layer or a rear-surface electrode formed on the substrate, which are overlapped each other such that the organic thin-film layer of the transfer material faces a receiving surface of the first laminate, thereby forming a laminate structure; (b) peeling the temporary support from the laminate structure to transfer the organic thin-film layer to the receiving surface of the first laminate; and (c) bonding a second laminate comprising a substrate and at least a rear-surface electrode or a transparent conductive layer formed on the substrate to the organic thin-film layer transferred onto the first laminate.

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